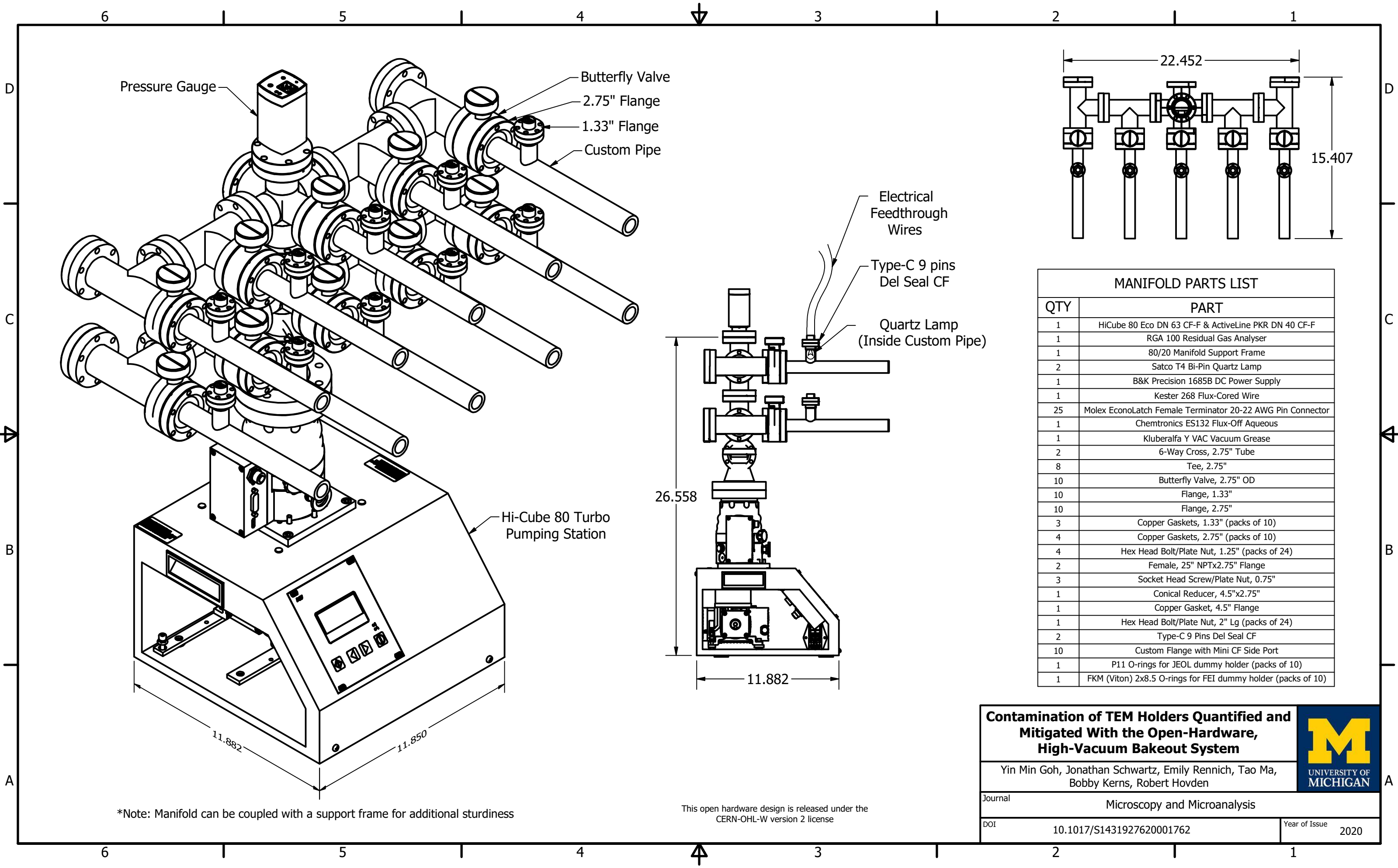




MANIFOLD PARTS LIST	
QTY	PART
1	HiCube 80 Eco DN 63 CF-F & ActiveLine PKR DN 40 CF-F
1	RGA 100 Residual Gas Analyser
1	80/20 Manifold Support Frame
2	Satco T4 Bi-Pin Quartz Lamp
1	B&K Precision 1685B DC Power Supply
1	Kester 268 Flux-Cored Wire
25	Molex EconoLatch Female Terminator 20-22 AWG Pin Connector
1	Chemtronics ES132 Flux-Off Aqueous
1	Kluberalfa Y VAC Vacuum Grease
2	6-Way Cross, 2.75" Tube
8	Tee, 2.75"
10	Butterfly Valve, 2.75" OD
10	Flange, 1.33"
10	Flange, 2.75"
3	Copper Gaskets, 1.33" (packs of 10)
4	Copper Gaskets, 2.75" (packs of 10)
4	Hex Head Bolt/Plate Nut, 1.25" (packs of 24)
2	Female, 25" NPTx2.75" Flange
3	Socket Head Screw/Plate Nut, 0.75"
1	Conical Reducer, 4.5"x2.75"
1	Copper Gasket, 4.5" Flange
1	Hex Head Bolt/Plate Nut, 2" Lg (packs of 24)
2	Type-C 9 Pins Del Seal CF
10	Custom Flange with Mini CF Side Port
1	P11 O-rings for JEOL dummy holder (packs of 10)
1	FKM (Viton) 2x8.5 O-rings for FEI dummy holder (packs of 10)

Contamination of TEM Holders Quantified and Mitigated With the Open-Hardware, High-Vacuum Bakeout System

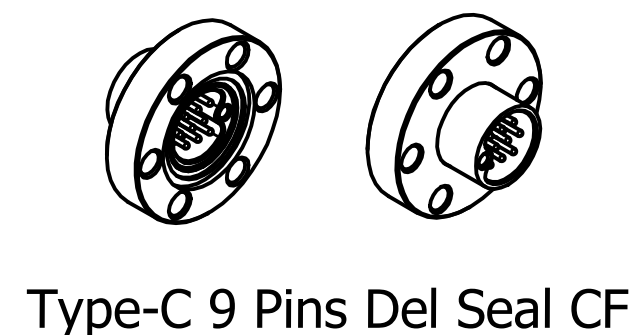
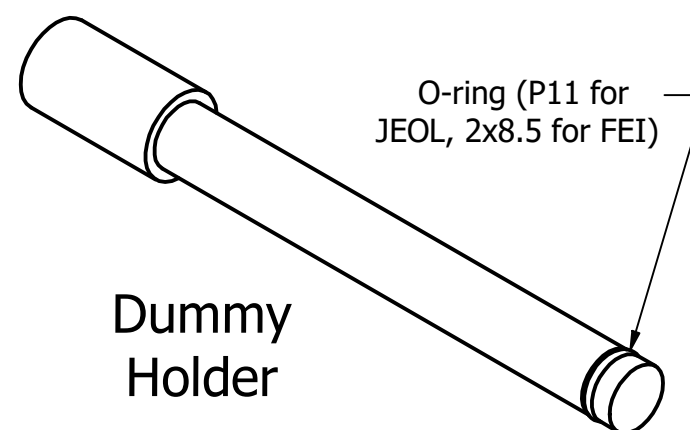
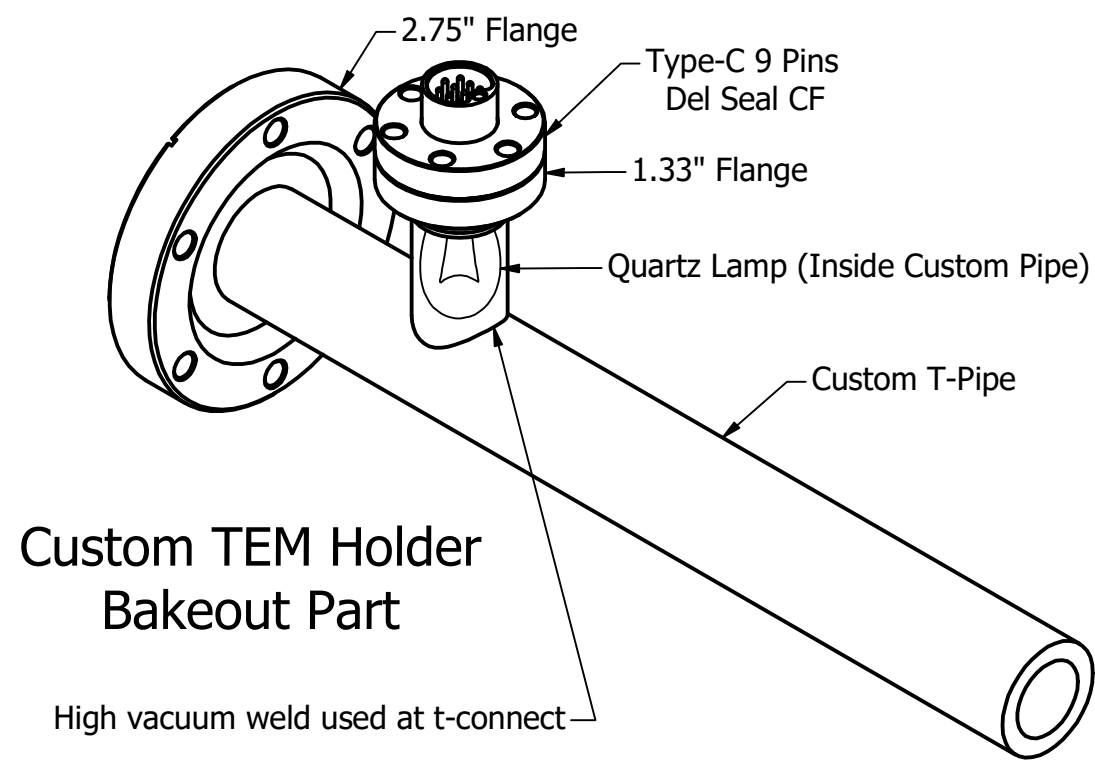
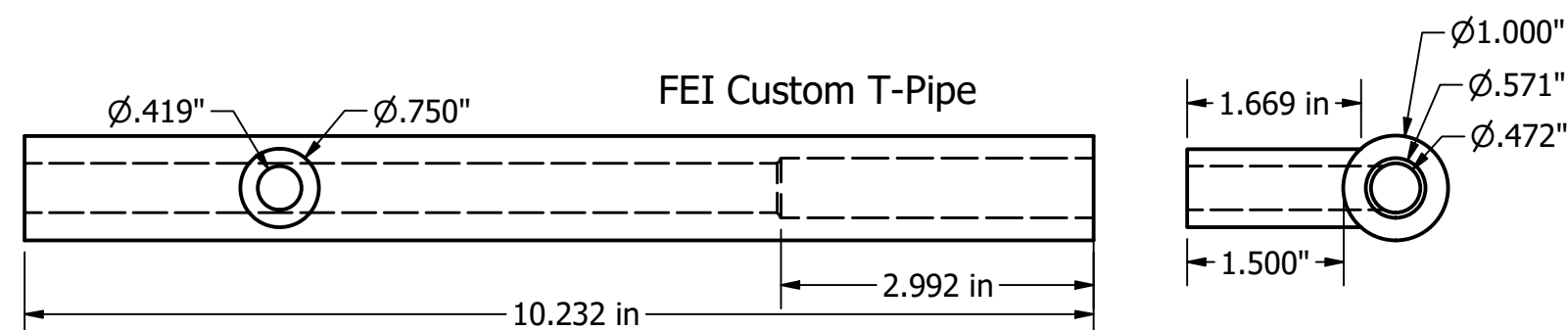
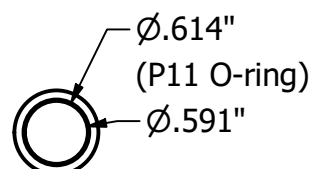
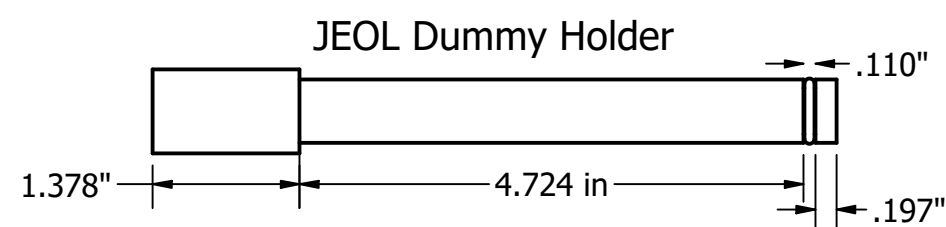
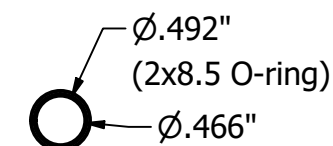
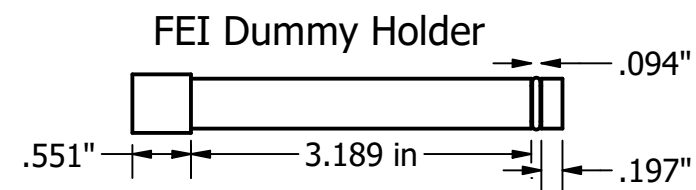
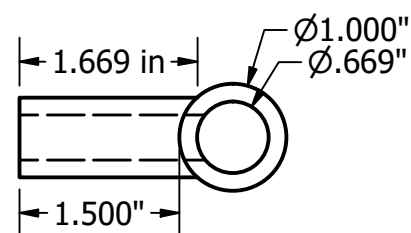
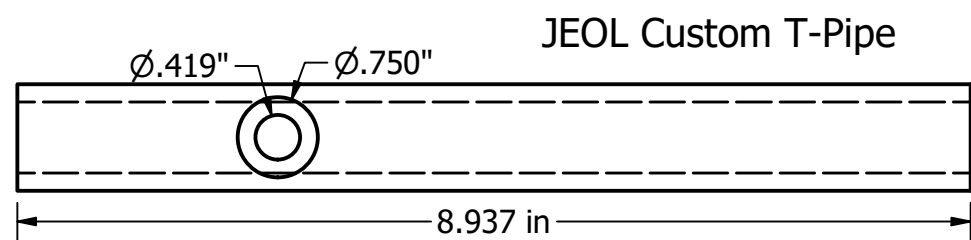
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